

INFORMATION DISCLOSURE STATEMENT (IDS) BY APPLICANT (FORM PTO-1449 Modified)	Application Number	10/701,306
	Filing Date (YYYY-MM-DD)	2003-11-04
	First Named Inventor	Hea Suk JUNG
	Art Unit	2816
	Examiner Name	Almo, Khareem E
	Attorney Docket Number	CU-3424

U.S. PATENTS

EXAMINER INITIAL	U.S. PATENT NUMBER	ISSUE DATE (YYYY-MM-DD)	PATENTEE	CLASS	SUB- CLASS	FILING DATE (YYYY-MM-DD)

U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	U.S. PATENT APPLICATION PUBLICATION NUMBER	PUBL. DATE (YYYY-MM-DD)	PATENTEE	CLASS	SUB- CLASS	FILING DATE (YYYY-MM-DD)

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	FOREIGN PATENT DOCUMENT NUMBER	COUNTRY CODE	KIND CODE	PUBL. DATE (YYYY-MM-DD)	NAME OF PATENTEE OR APPLICANT OF THE CITED DOCUMENT	TRANSLATION YES NO	
/K.A./	1 002 369	EP	B1	2000-05-24	Micron Technology Inc		
/K.A./	2000-163999	JP	A	2000-06-16	Fujitsu Ltd		
/K.A./	2002-043934	JP	A	2002-02-08	Hitachi Ltd Hitachi Device Eng Co Ltd		

NON-PATENT LITERATURE DOCUMENTS

EXAMINER INITIAL	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial symposium catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	TRANSLATION YES NO	

EXAMINER	/Khareem Almo/ (04/09/2009)	DATE CONSIDERED	04/09/2009
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EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

(Form PTO-1449)
03-30-09.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.A./